

Addressing technological challenges on sensor-electronics hybridization for compact silicon tungsten electromagnetic calorimeters

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CALICE -type
calorimeter



FCAL-type
calorimeter



**Common R&D: module hybridization.
Assembly lab being set-up at IFIC**

A.I., C. Blanch, C. Orero, M. Almanza, S. Huang



- ▷ High granular silicon-ecals : what for?
- ▷ SiW-ECAL challenges
- ▷ Ultra Compact ECAL challenges
- ▷ Summary



▶ Higgs Factories – Particle FLOW calorimeters

- All projects (linear/circular) consider Particle Flow detector options
- Requires high granular and compact sandwich calorimeters (i.e. ECAL silicon + tungsten)
- Fully embedded electronics & minimal moliere radius

▶ Strong-Field QED experiments (LUXE)

- Features two silicon-tungsten highly granular and compact ECALs (CALICE and FCAL adaptations). Eu.XFEL pulsed electron beam (as ILC)
- Excitement and ambitious program to study SFQED in high detail → **uncharted territory**
- From the point of view of Higgs Factories: also a stepping stone on detector R&D program

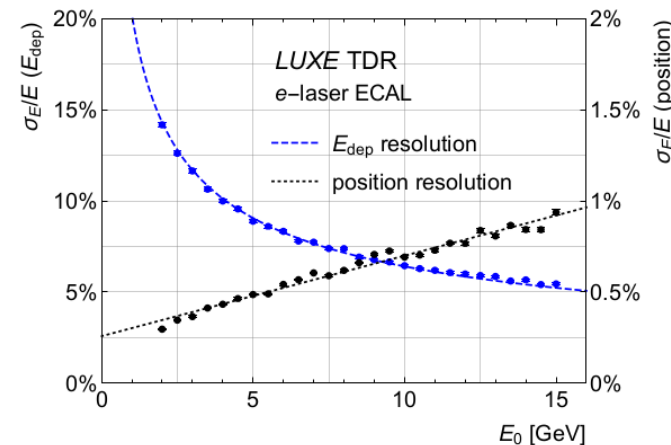
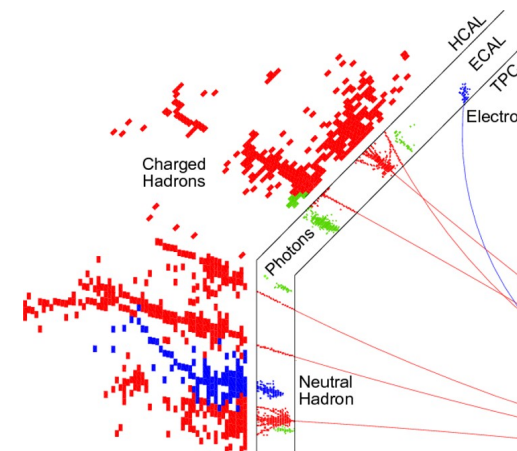
▶ Dark Photon, ALPs Experiments

- LUXE-NPOD, ...

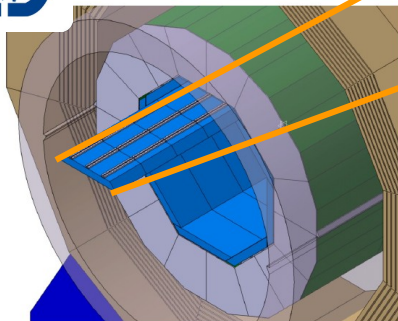
SiW ECAL Technological requirements

Sandwich calorimeters – High Granularity –

- ▷ Particle Flow, Luminosity measurements, Energy Flow, shower overlapping
- ▷ Tungsten as absorber material
 - Narrow showers
 - Assures compact design
- ▷ Silicon as active material
 - Support compact designs
 - Allows pixelisation → good position resolution
 - Robust technology
 - Excellent signal/noise ratio

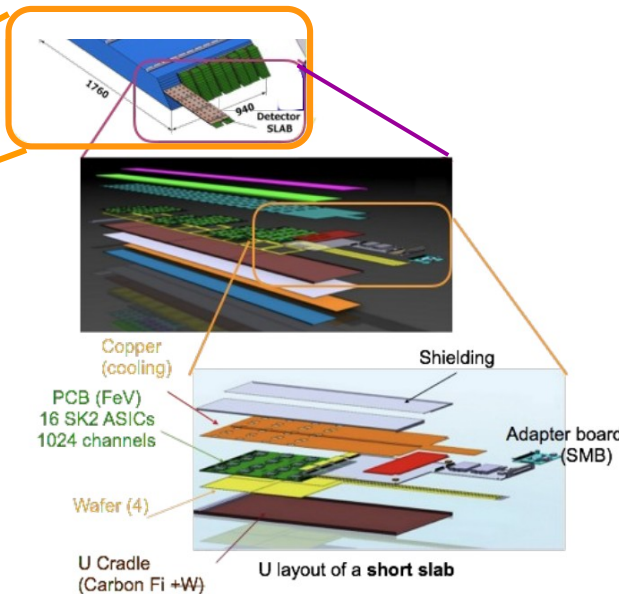


Requirements: highly integrated



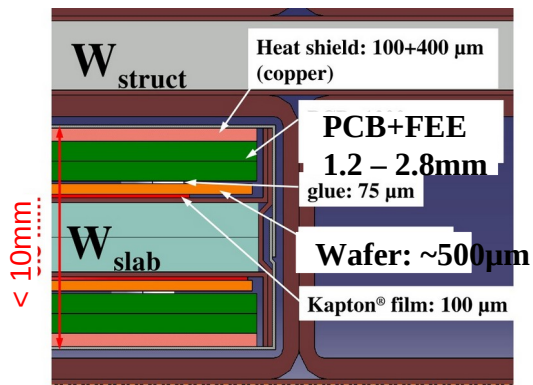
The SiW ECal in the ILD Detector

SiW Ecal

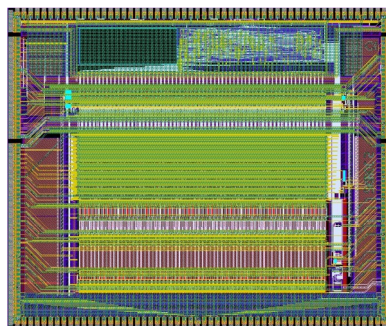


Barrel

- ▷ $O(10^4)$ slabs
 - ▷ $O(10^5)$ ASUs
(PCB+wafer+ASIC+DigReadout)
 - ▷ $O(10^{6-7})$ ASICS
 - ▷ $O(10^8)$ cells
 - 2000 m² of Si
 - ▷ 130 T of tungsten
- Cell size of 5x5 mm → all cells are self triggered + zero suppression**



e.g. SKIROC (for SiW Ecal)



Size 7.5 mm x 8.7 mm,

64 channels

Dual gain, autotrigger, powerpulsed

(goal of 25uW / chn)



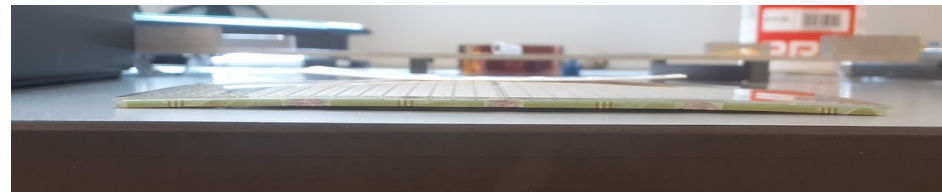
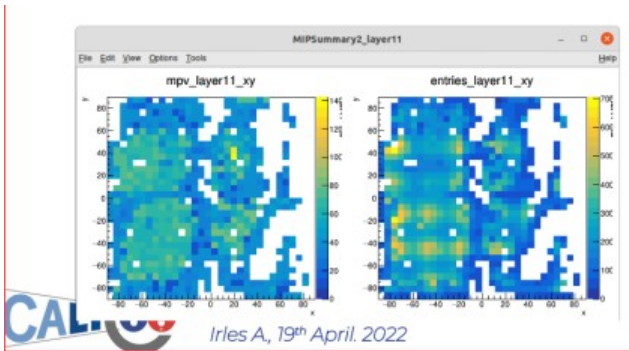
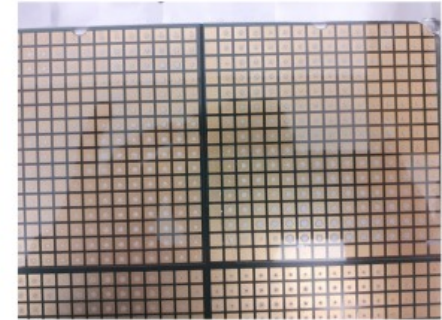
SiW ECAL: the basics

- ▷ Very dense PCBs
- ▷ 4 silicon sensors
 - PiN Diodes of $90 \times 90 \text{ mm}^2$
 - $55 \times 55 \text{ mm}^2$ cells
- ▷ No space for wirebonding
- ▷ Glue with conductive epoxy+silver mixes
 - Low temperature curing (40-80 degrees)
- ▷ **Delamination observed** in several modules → partial (or almost total) **wafer-pcb separation** with time

256 P-I-N diode
0.25 cm² each
9 x 9 cm² total area

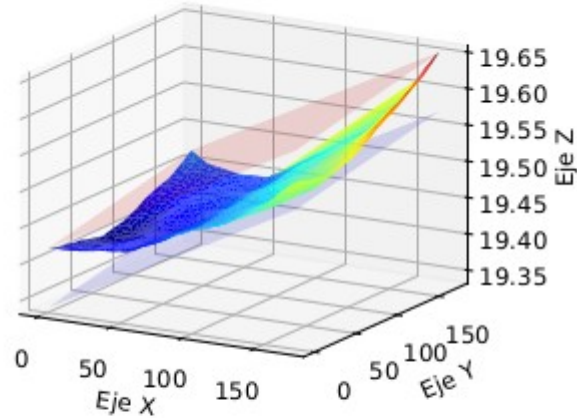
EUDET layout

Prototype from Hamamatsu



SiW ECAL: PCB planarity

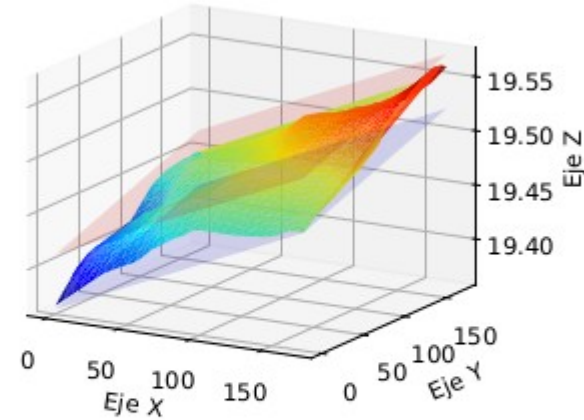
ISOMETRIC VIEW



Naked PCB planarity meas.



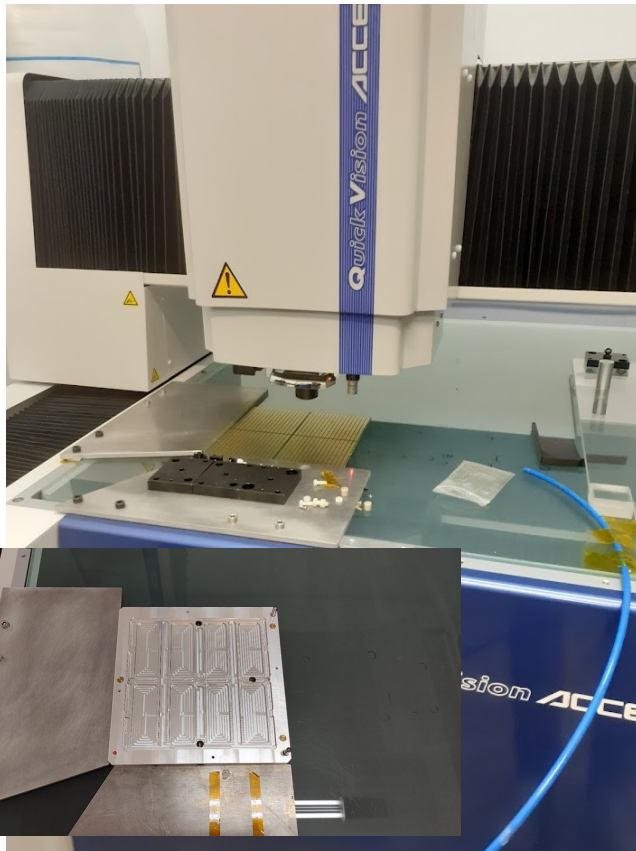
ISOMETRIC VIEW



Same PCB after keeping it in dry storage for 10 days



SiW ECAL: PCB planarity



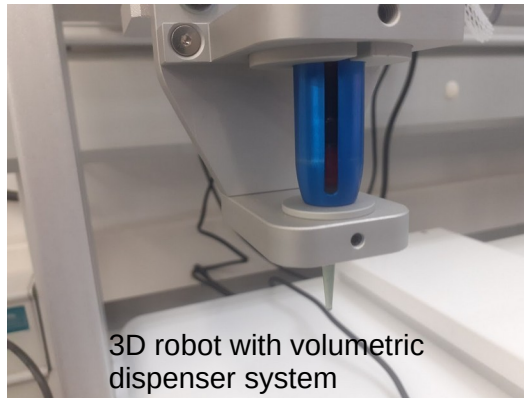
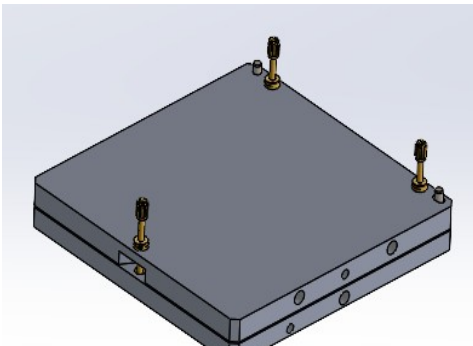
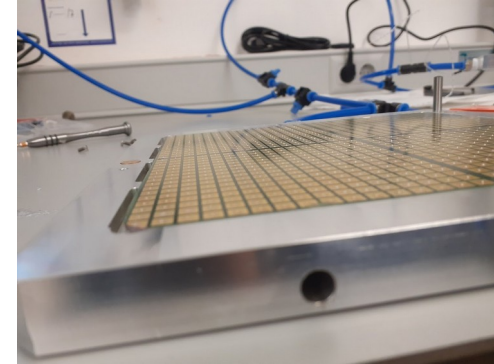
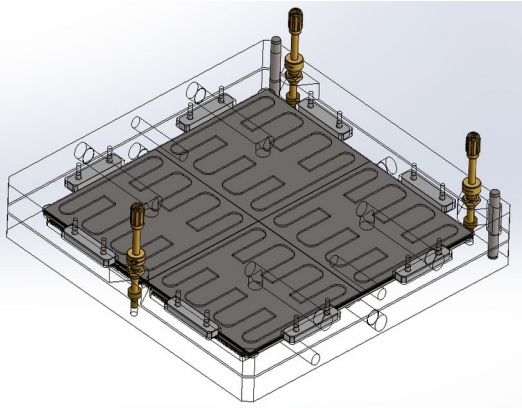
- ▷ Planarity measurements being done consistently and under different storage conditions
- ▷ Naked board PCB planarity : varies between 80-160um depending on the board
- ▷ Similar planarity for boards equipped with components (less statistics)
- ▷ Planarity depends on storage conditions. Systematic improvement observed.
 - Global planarity improves in ~60% (50-80um)
 - Local differences are larger, up to few 100um

Mitutoyo Quick Vision Accel, Modelo 808

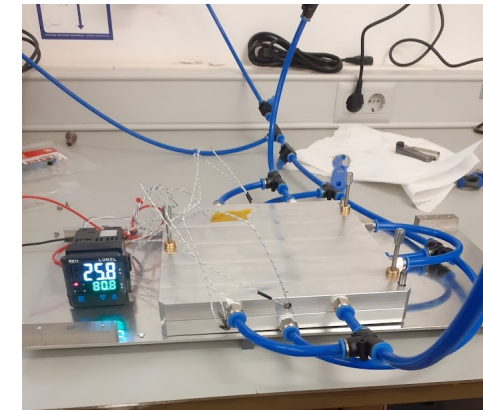
Measurements by C. Orero

SiW ECAL hybridization / integration

- ▷ Cluing training + tests ongoing
- ▷ Setup in new clean installation being deployed at IFIC



3D robot with volumetric dispenser system

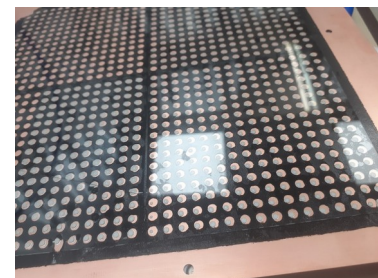
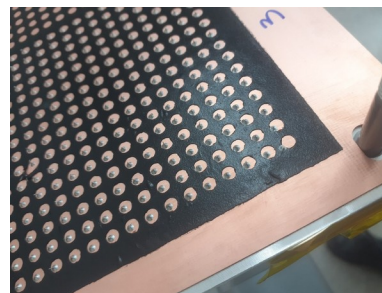
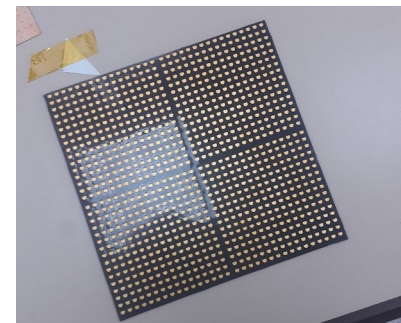
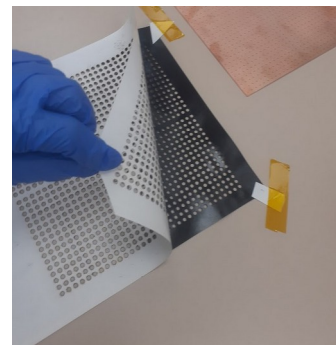
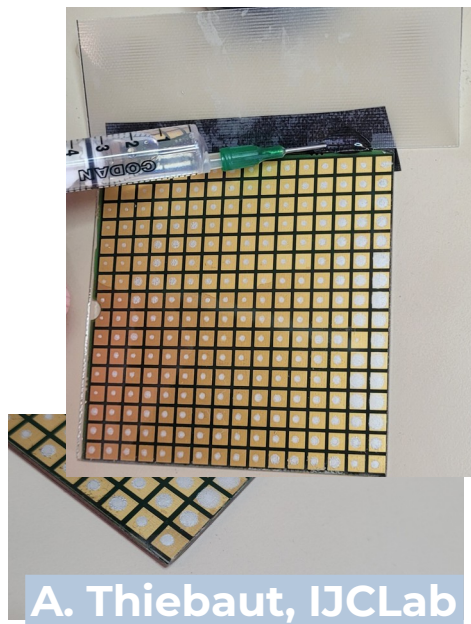
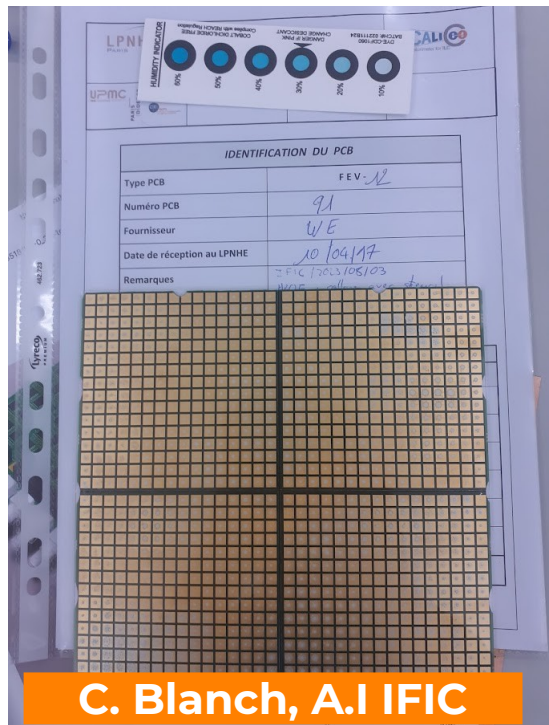


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SiW ECAL: double adhesive solution for hybridization

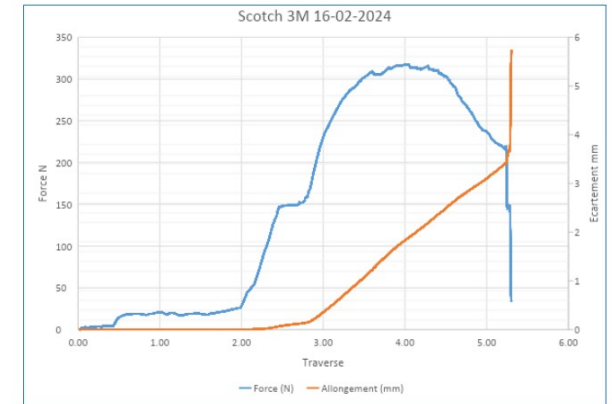
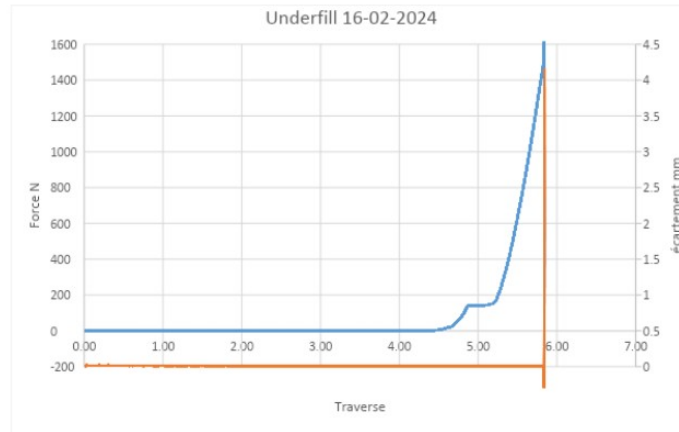
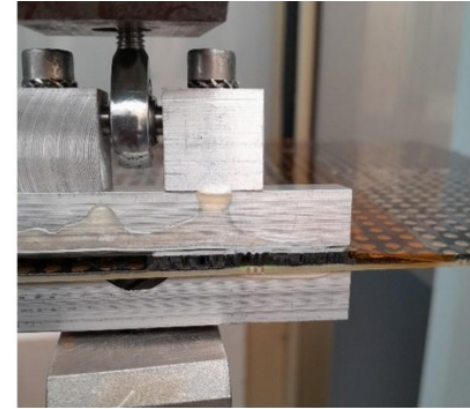
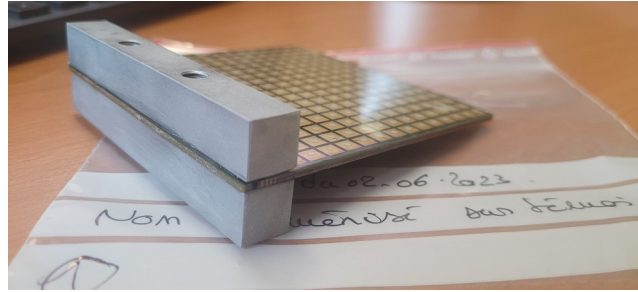
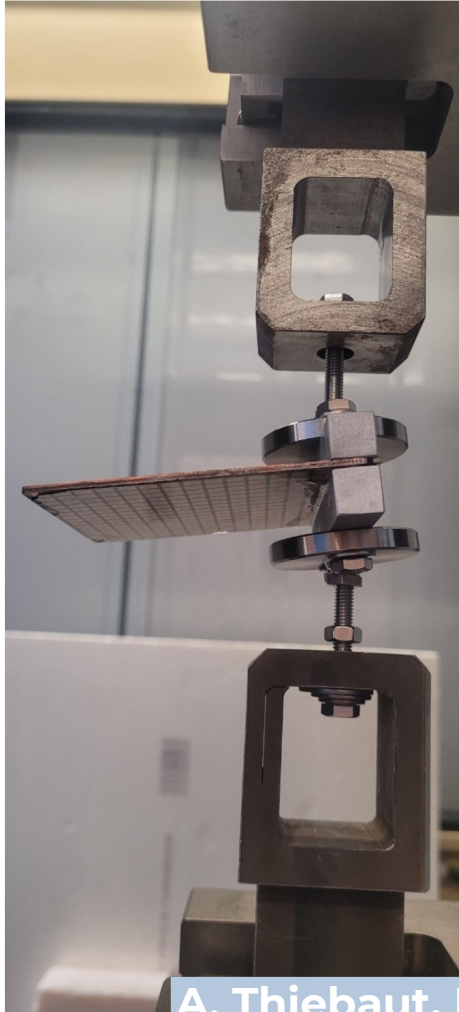
- ▷ Keeping control on the deformation of PCB
 - Wip: study of the stress forces involved (IJCLab)
- ▷ Two solutions being explored, both still with epoxy-silver glue dots for the electrical conductivity
 - Undefill glue (EPO-TEK 301-2FL) → involves second curing.
 - Double tape (3M 5907-F) used as stencil/mask for adherence



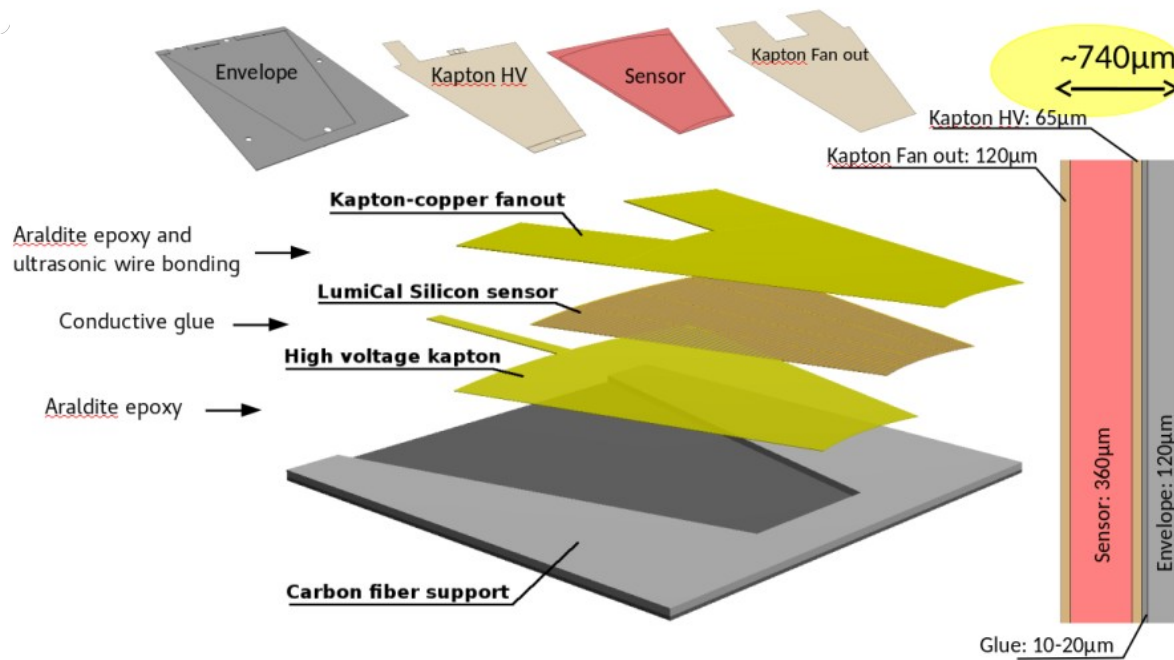
C. Blanch, A.I IFIC



Mechanical tests



A. Thiebaut, IJCLab



Forward region (LUMICAL)

- ▷ Ultra thin layers <1mm for minimal Moliere Radius
- ▷ Not embedded electronics
- ▷ Higher radiation levels

Figure 5.13. Structure of a sensitive layer of the LumiCAL calorimeter.

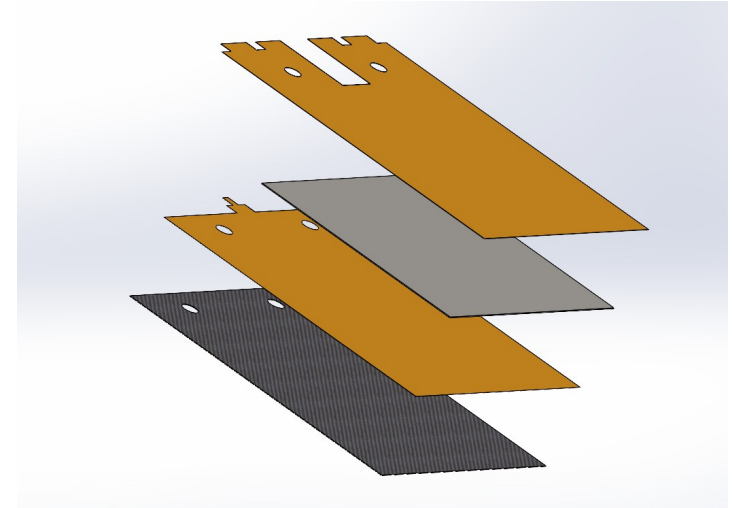
Ultra Compact Calo Hybridization

▷ Large sensors ($9 \times 9 \text{cm}^2$) and **flexible PCBs (compact calo)**

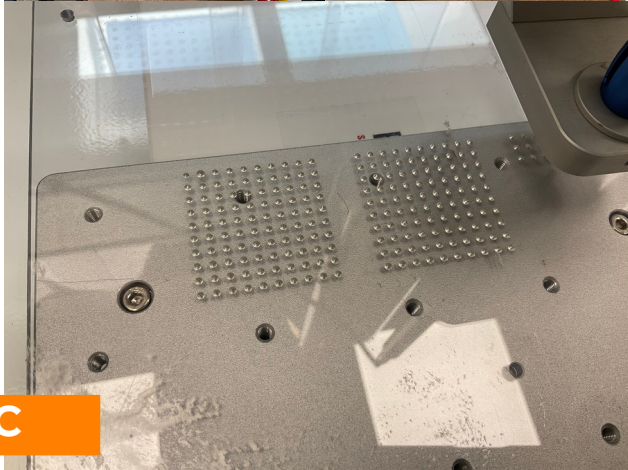
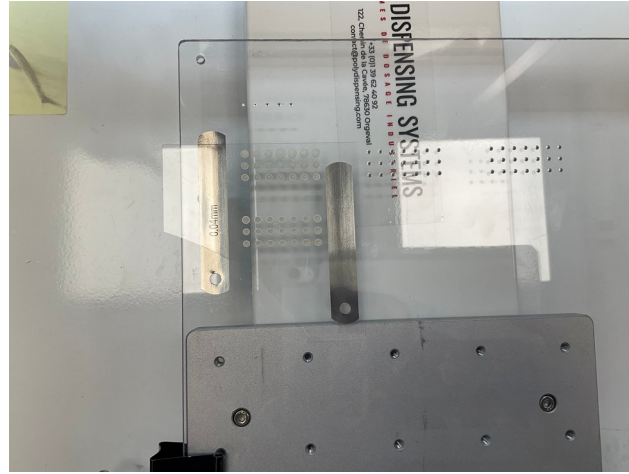
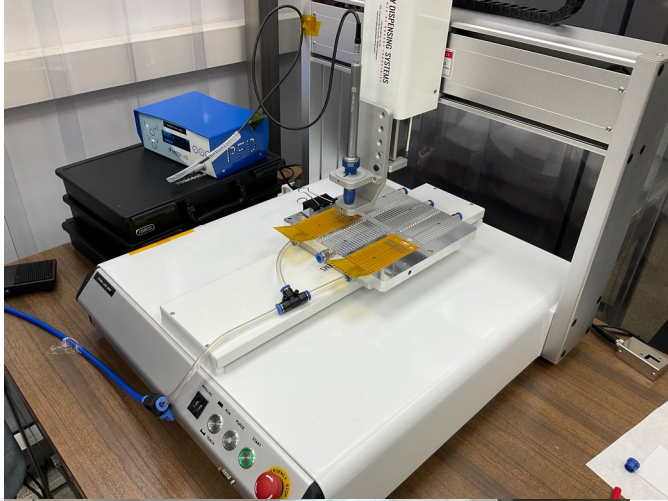
▷ **Material budget, thickness:**

- **Total bellow 1mm**
- 200um CF + 320um sensor
- ~500um for fanout + HV kapton + 3 layers of glue/Adhesive

▷ The main challenge is to obtain a very thin layer of glue, with high repeatability



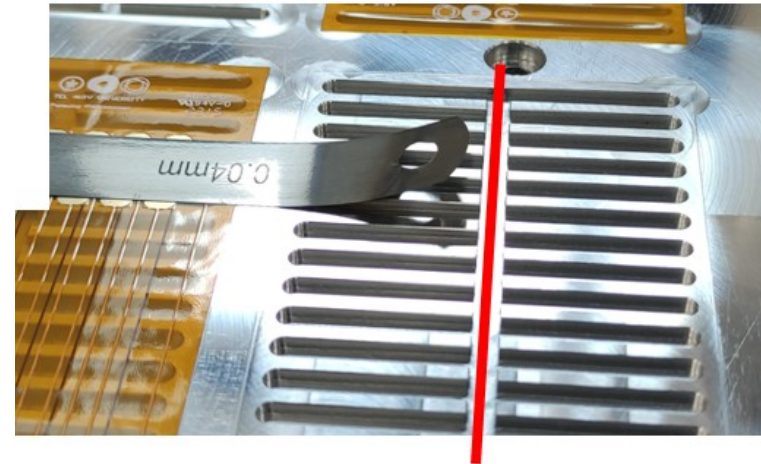
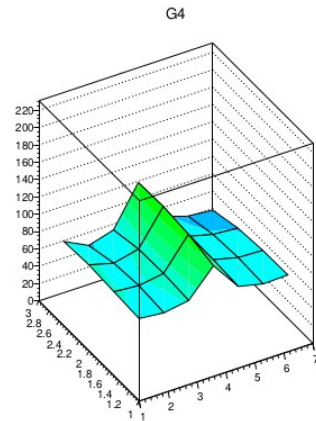
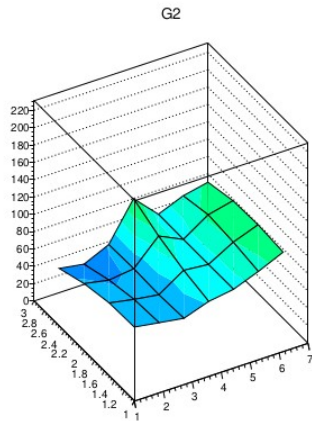
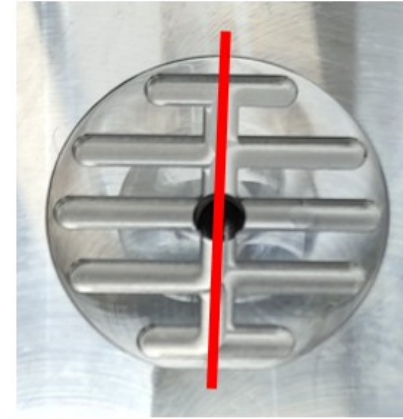
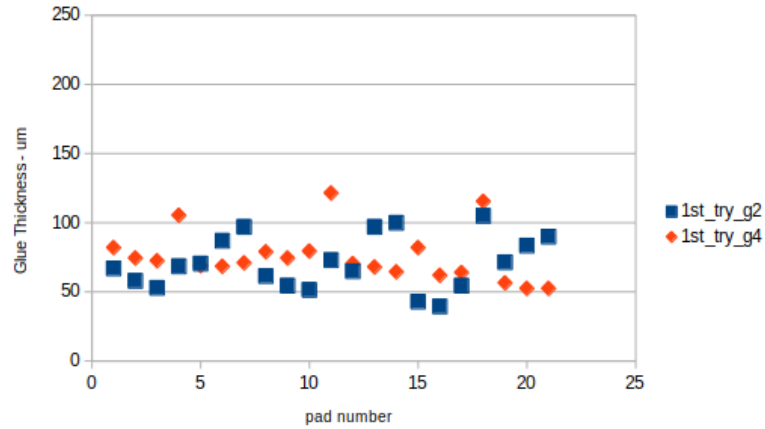
Ultra Compact Calo Hybridization



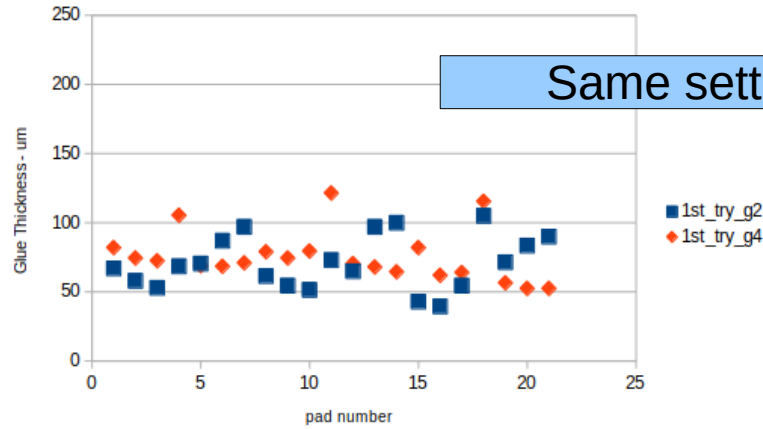
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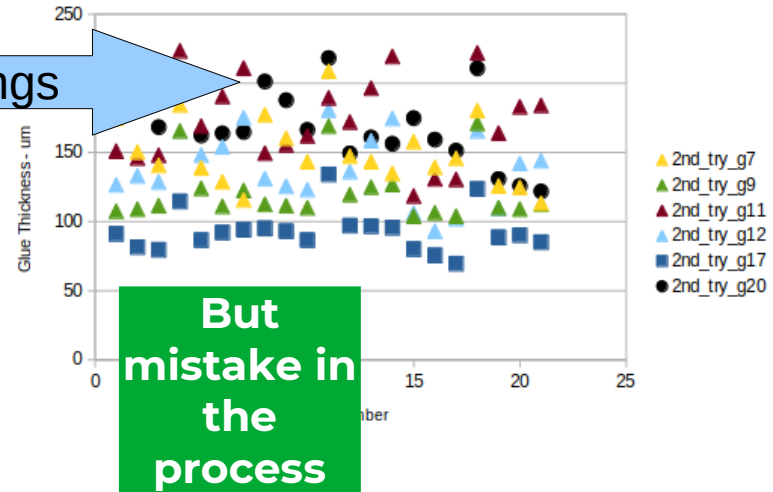
Glue thickness study



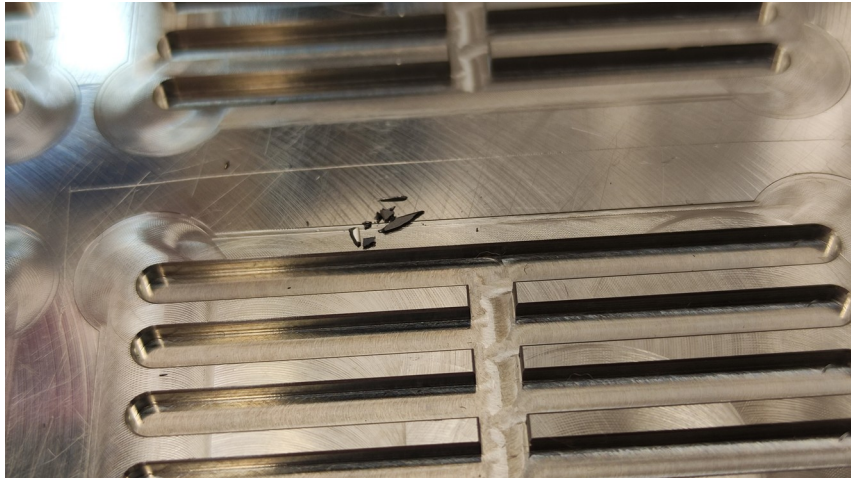
Glue thickness study



Same settings

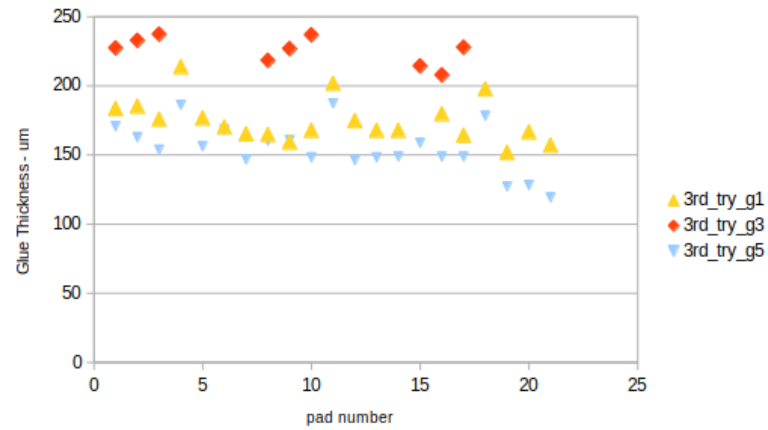
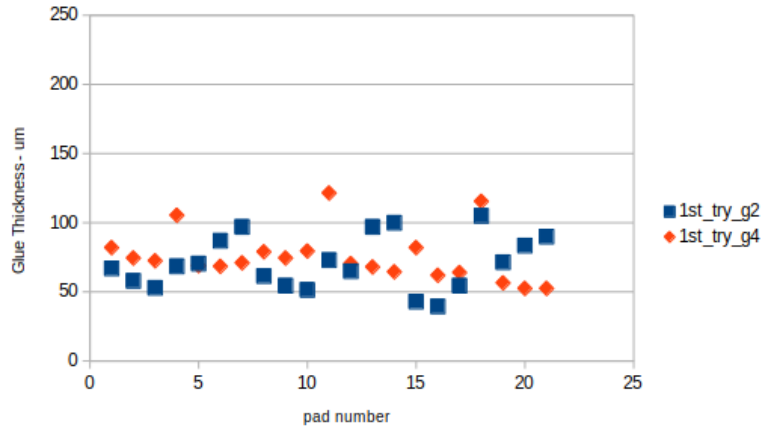


But mistake in the process



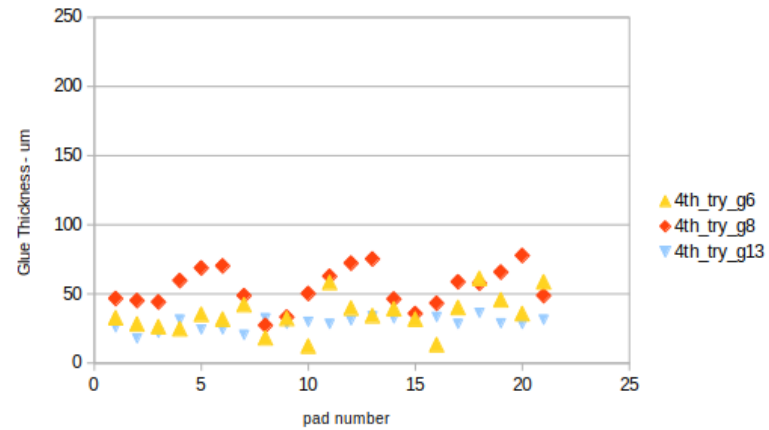
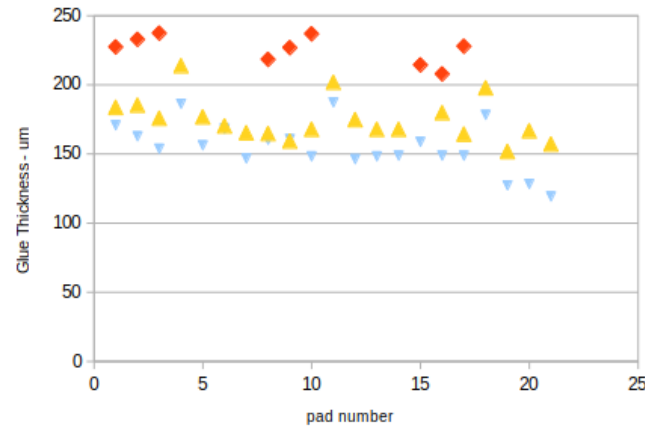
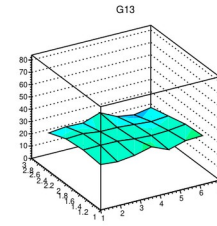
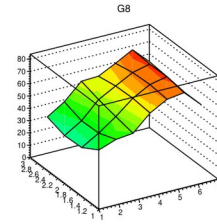
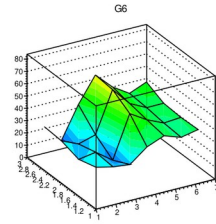
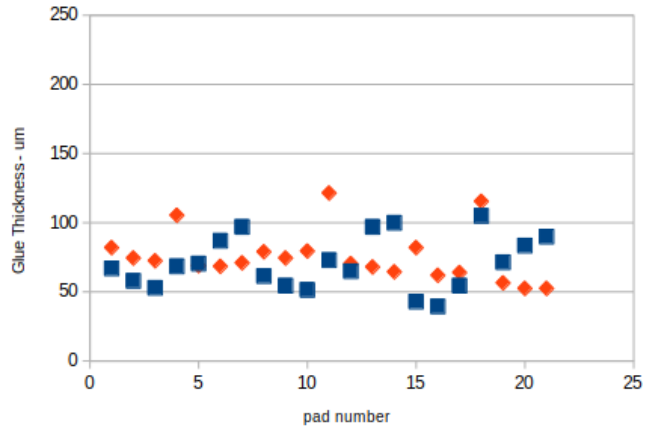
Glue thickness study

Change of dosification needle



Glue thickness study

Change of dosification needle

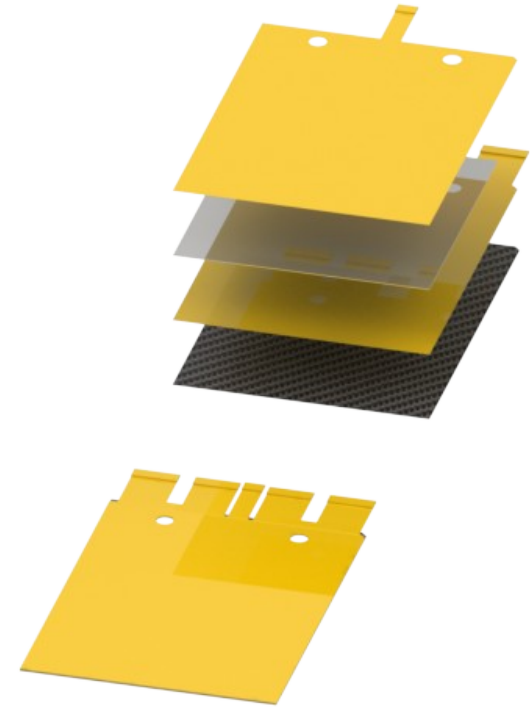
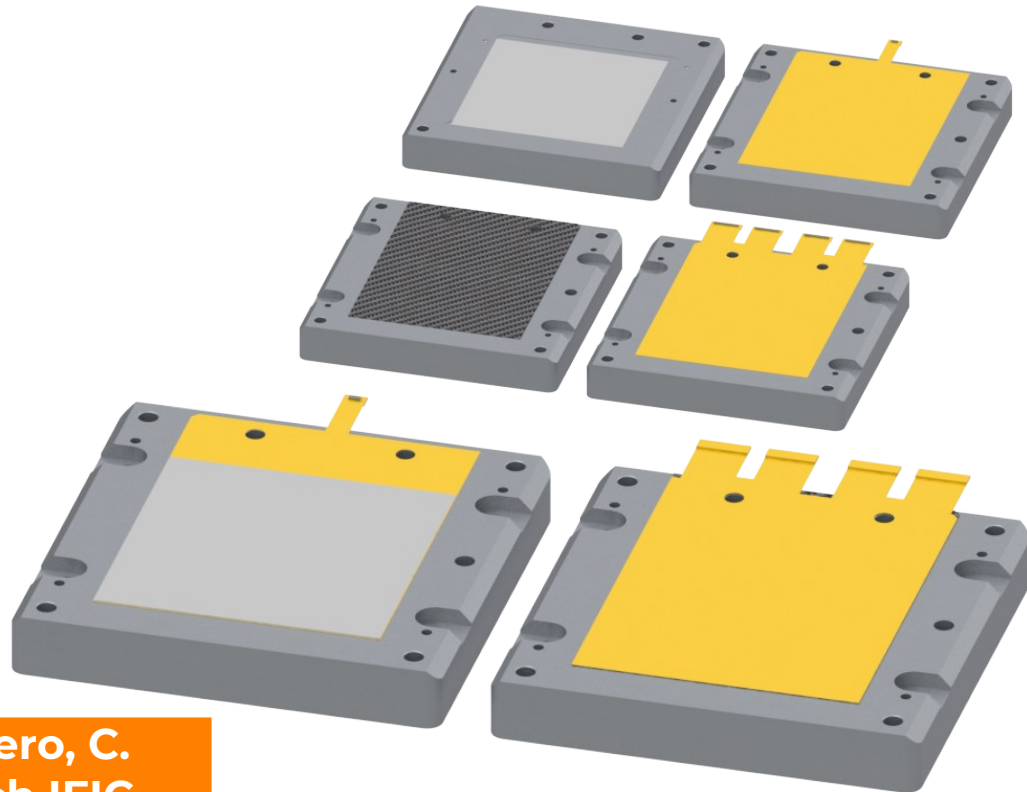


Release of vacuum before curing



Tooling for precise hybridization

▷ **Work in progress** – design and optimization of the gluing process



C. Orero, C.
Blanch IFIC



- ▷ High granular silicon ECALs with embedded electronics and compact design poses several challenging on the hybridization.
- ▷ Comprehensive studies been pursued within detector R&D collaborations (DRD6) but also driven by specific projects: ILD, LUXE

Thanks





DRD6 - Higgs Factories - LUXE

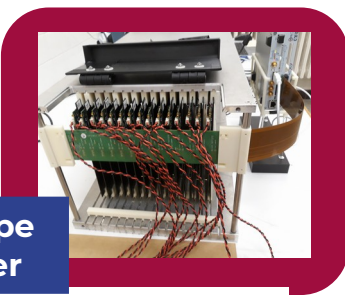


FCAL-type calorimeter

***e*-laser setup
(Not in scale)**

ILD LUMICAL
(Compact ECAL)

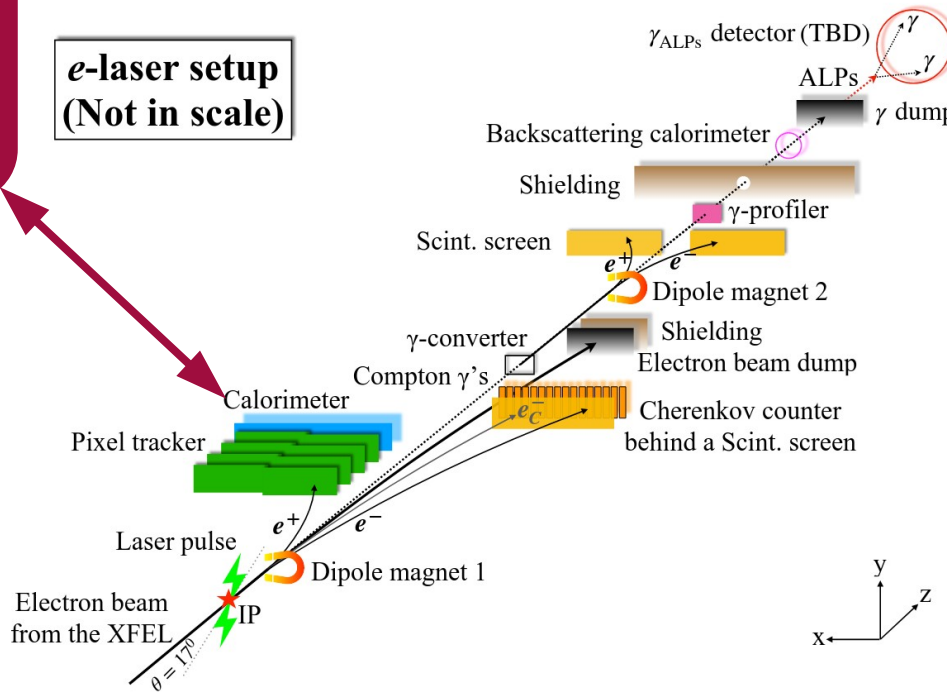
adapted for high
rate positron
measurement at
LUXE



CALICE -type calorimeter

ILD Barrel
SiECAL

adapted for
BSM direct
searches with
high angular
resolution for
photon
separation



LUXE

Strong-Field QED experiments

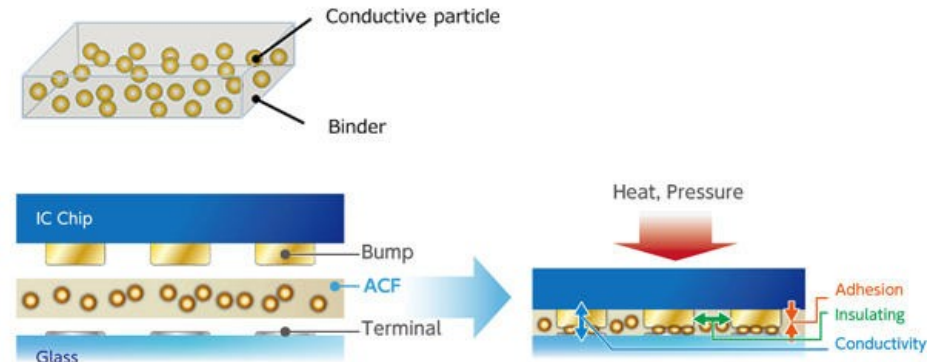
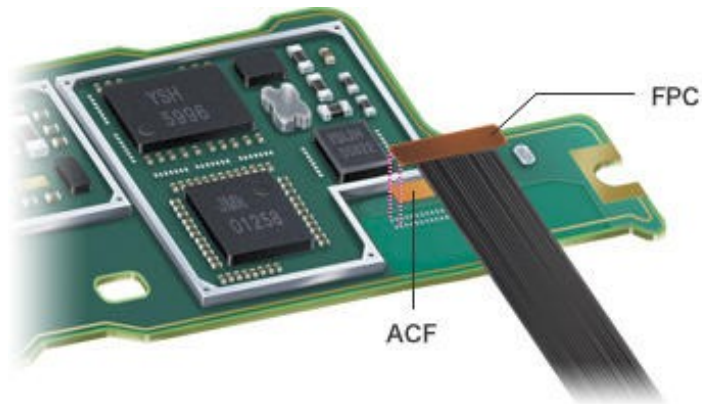


Si ECAL hybridization / integration

Common R&D Mid-term

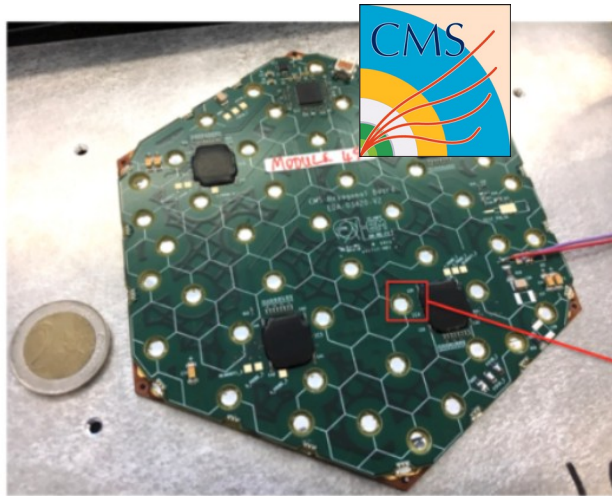
▷ R&D Alternative solutions:

- Check what the industry is doing (smartphones, LCD screens, etc)
- → Anisotropic Conductive Films, Micropearls... (investigated also in the context of AIDAInnova & LUXE)
- Affordable for large surface sensors in rigid PCBs ??

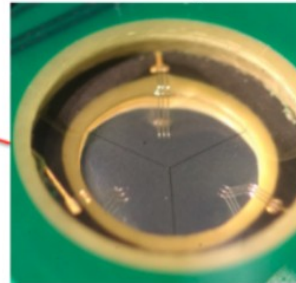


▷ Very dense **PCBs**:

- i.e. at SiW-ECAL they are known as featuring 1024 readout channels (with digital, analogue, clock signals) in a $18 \times 18 \text{ cm}^2$ board



Wire bonding from PCB to silicon through holes



CMS HGCal Hexaboard

Wire bonding from PCB to silicon through holes



SiW-ECAL current prototype solution.

Meets industry requirements → bulky components **compromise compactness**

LUXE

membership of Russian institutes suspended



UNIVERSITY OF PLYMOUTH



ECOLE POLYTECHNIQUE



université PARIS-SACLAY



ALMA MATER STUDIORUM UNIVERSITÀ DI BOLOGNA



UNIVERSITÀ DEGLI STUDI DI PADOVA



HELMHOLTZ Helmholtz-Institut Jena



AGH AKADEMY OF SCIENCES AND TECHNOLOGY



TEL AVIV UNIVERSITY

IFIC-Lab for ECAL hybridization



- ▷ **New facility and capabilities at IFIC**
- ▷ **Funding: CIDEAGENT/ASFAE/CNS** → In line with ECFA – R&D roadmap, DRD6, Future Colliders
- ▷ **IFIC will become** the hub for module hybridization R&D / production / commissioning for DRD6 Si-ECALs and for the LUXE experiment

